

MICRON.100C1

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

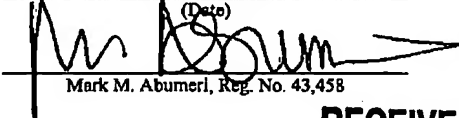
Appl. No. : 10/608,913
Applicant : Craig A. Hickman
Filed : June 26, 2003
For : DEVICE AND METHOD OF
CORRECTING EXPOSURE
DEFECTS IN
PHOTOLITHOGRAPHY
Group Art Unit : 2851
Examiner : Rodney Evan Fuller
Attny Docket No. : MICRON.100C1
Customer No. : 20,995

Confirmation No. 7050

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AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION

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Alexandria, VA 22313-1450

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Dear Sir:

In response to the final Office Action of June 10, 2004, the Applicant submits the following amendment and remarks for consideration in connection with the above-captioned application.

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.

Knobbe Martens Olson & Bear LLP**Intellectual Property Law**

550 West C Street
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San Diego CA 92101
Tel 619-235-8550
Fax 619-235-0176
kmo.com

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TO: Examiner Rodney Evan Fuller

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FACSIMILE NO.: 703-872-9306

FROM: Mark M. Abumeri

CLIENT CODE: MICRON.100C1

APPLICATION NO.: 10/608/913

ENCLOSURE: Amendment and Response to Final Office Action in eight (8) pages

PAGES: 10 (INCLUDING THIS SHEET)

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Of Counsel
Louis J. Knobbe*
Jerry R. Sailer

Japanese Patent Atty
Katsuhiko Arai
Tomohisa Sugiyama

Korean Patent Atty
Mincheol Kim
Heungsoo Choi

Scientists & Engineers
(Non-Lawyers)

Raymond J. Saleniks**
Khurram Rahman, Ph.D.
Jennifer Haynes, Ph.D.**
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W. Frank Dauser
Lang J. McHardy**
Karen J. Lenker
Chris Westberg, Ph.D.
Eric B. Ives, Ph.D.**
Raymond D. Smith, Ph.D.

* A Professional Corporation
† Also Barrister At Law (reg. in Wales)
** U.S. Patent Agent
†† Also Solicitor (reg. in Wales)

OFFICIAL

2040 Main Street
14th Floor
Irvine, CA 92614
Tel 949-760-0404
Fax 949-760-8502

201 California Street
Suite 1150
San Francisco CA 94111
Tel 415-834-4114
Fax 415-834-4111

1901 Avenue of the Stars
Suite 1500
Los Angeles CA 90067
Tel 310-551-3450
Fax 310-551-3458

3403 Tenth Street
Suite 700
Riverside CA 92501
Tel 951-781-0231
Fax 951-781-4507

1114 Marsh Street
San Luis Obispo CA 93401
Tel 805-547-5580
Fax 805-547-5580

Docket No.: MICRON.100C1

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AMENDMENT / RESPONSE TRANSMITTAL

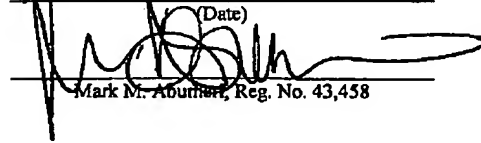
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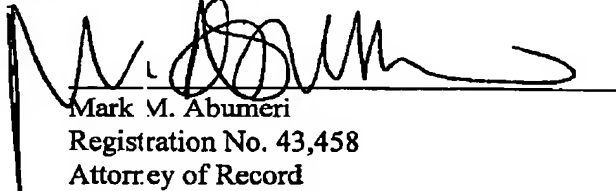
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Mark M. Abumeri
 Registration No. 43,458
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